

English Abstract fo Japanese Patent 63-028417

Liq. chemical circulating system - preventing filter mesh and pressure feed pump from being thermally deformed

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Number of Countries: 001 Number of Patents: 001

Patent Family:

Patent No	Kind	Date	Applicat No	Kind	Date	Week
JP 63028417	A	19880206	JP 86169508	A	19860718	198811 B

Abstract (Basic): JP 63028417 A

Part of treating vessel liq. chemical, heated at high temp. is removed outside, and cooled to a given temp.. After filtration to remove insol. matter in the cooled liq. chemical, the filtrate is heated at a specific temp. and is circulated to the treating vessel.

ADVANTAGE - Filter mesh and pressure feed pump are not thermally deformed.